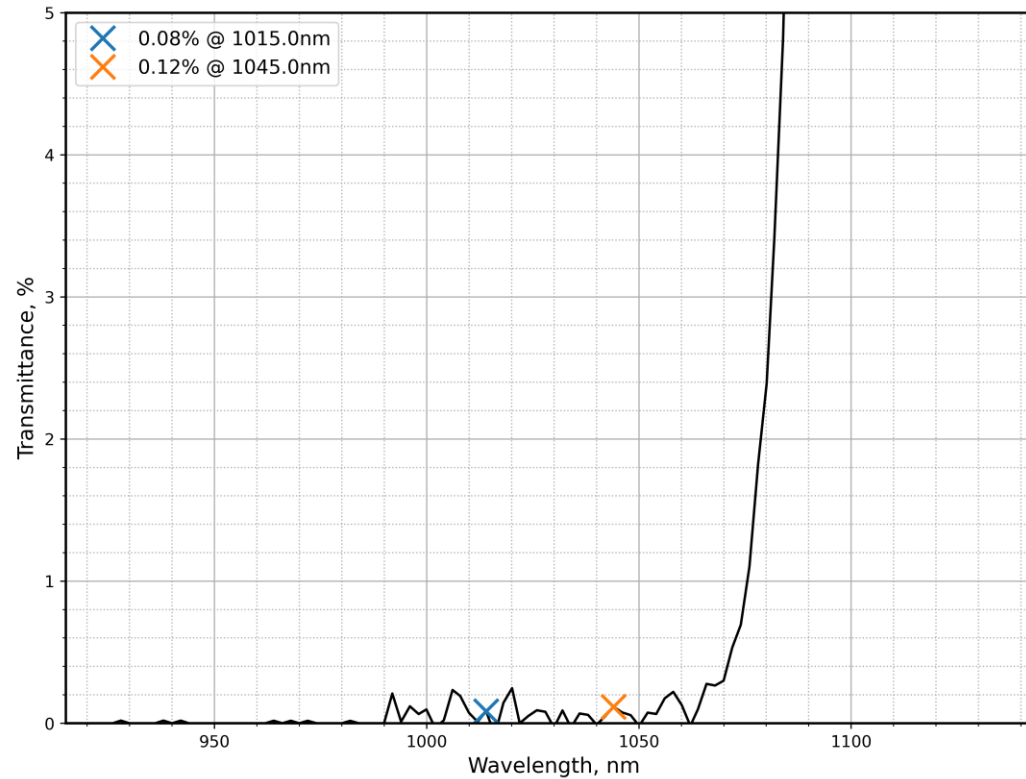


S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI=68(+/-0.5) deg  
 S2:  $AR_p(R_p < 0.5\%, R_s < 20\%)$  @ 1010-1050 nm, AOI=68(+/-0.5) deg



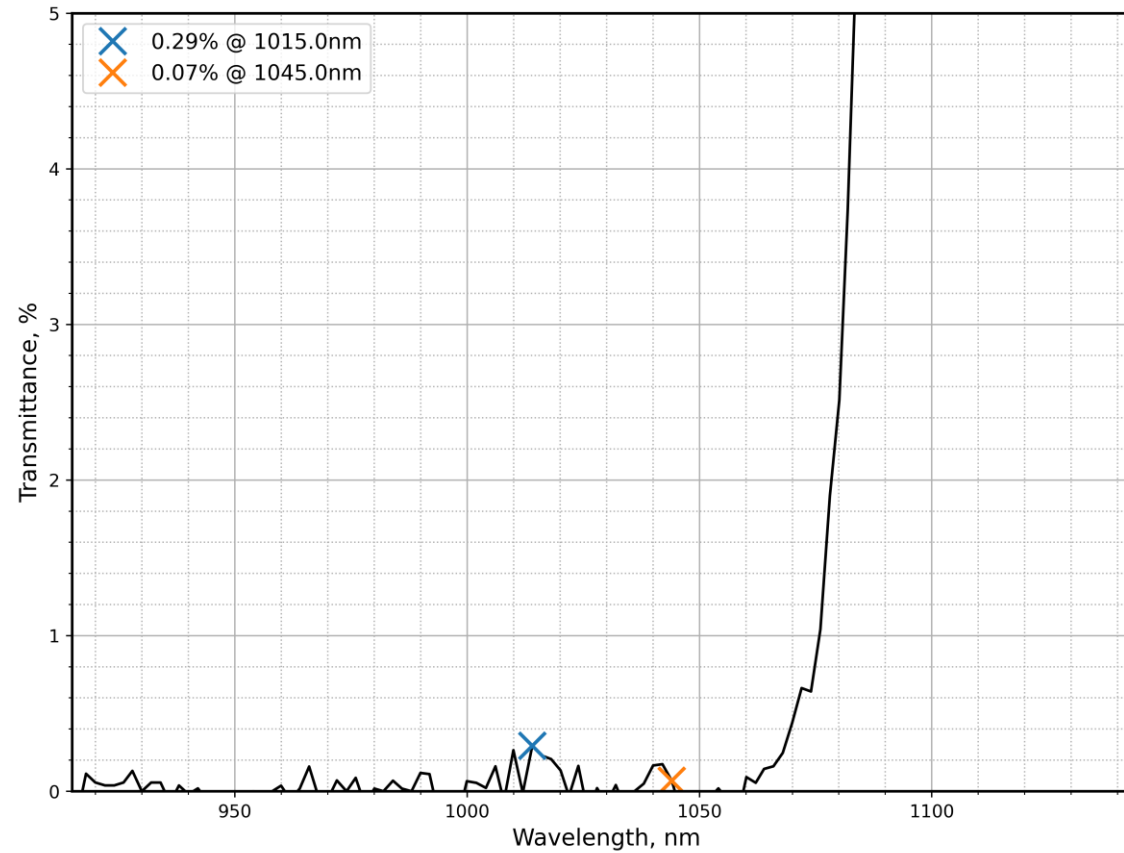
PO7662 Ts i68

Fig. 1.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%

S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI=68(+/-0.5) deg  
 S2:  $AR_p(R_p < 0.5\%, R_s < 20\%)$  @ 1010-1050 nm, AOI=68(+/-0.5) deg



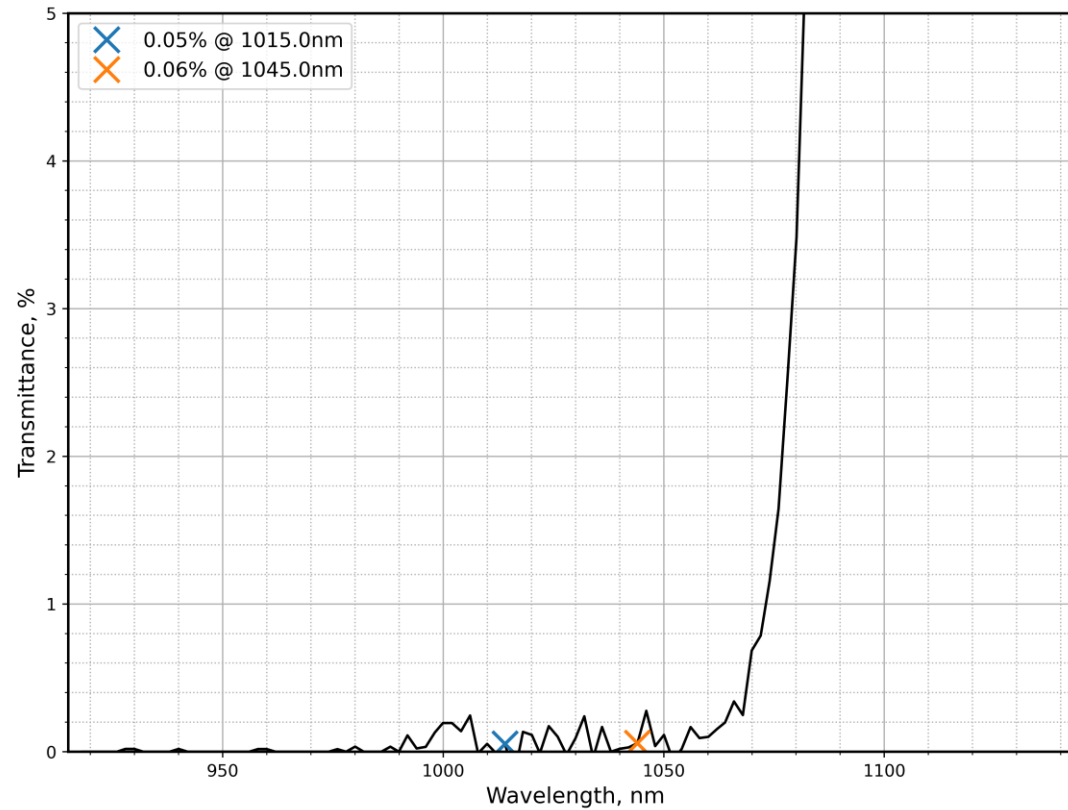
PO7662 Ts i68

Fig. 2.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%

S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI=68(+/-0.5) deg  
S2:  $AR_p(R_p < 0.5\%$ ,  $R_s < 20\%$ ) @ 1010-1050 nm, AOI=68(+/-0.5) deg



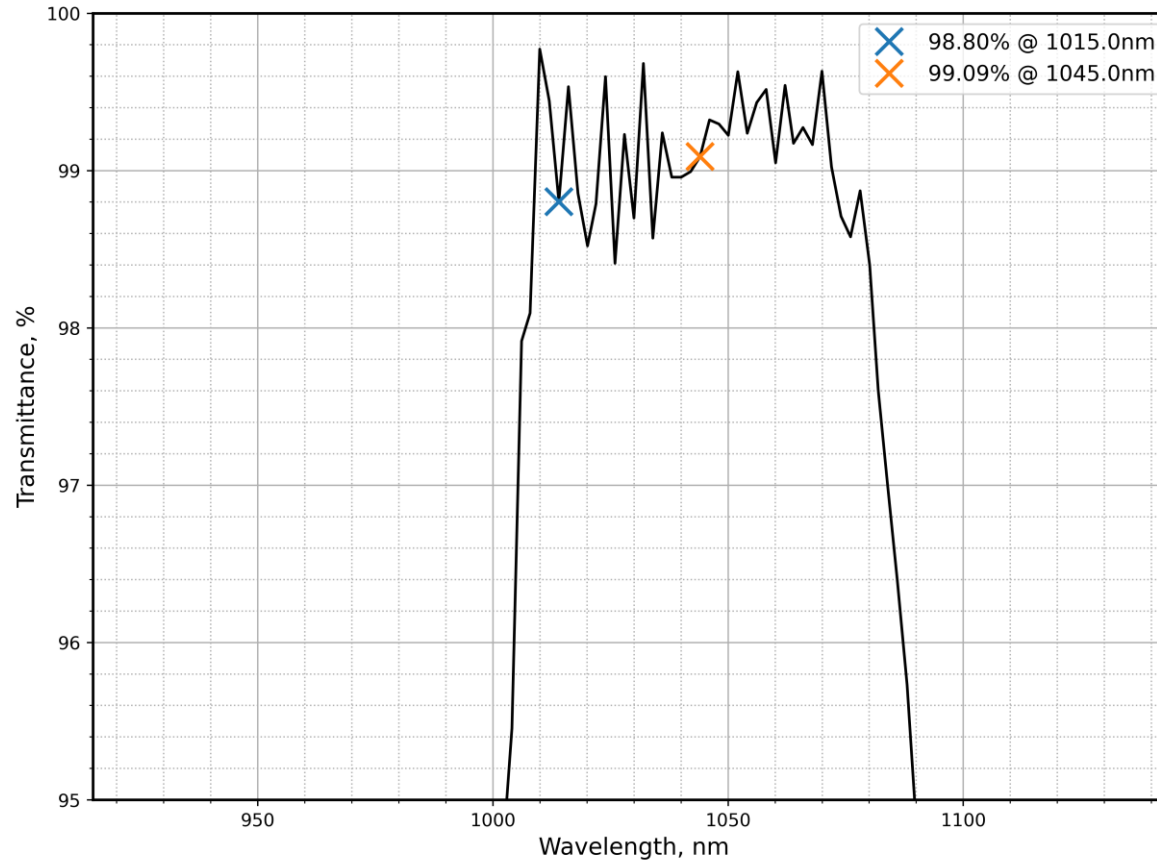
PO7662 Ts i68

Fig. 3.

SIDE MEASURED: S1+S2 (good component)

COMMENTS:

S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI=68(+/-0.5) deg  
 S2:  $AR_p(R_p < 0.5\%, R_s < 20\%)$  @ 1010-1050 nm, AOI=68(+/-0.5) deg



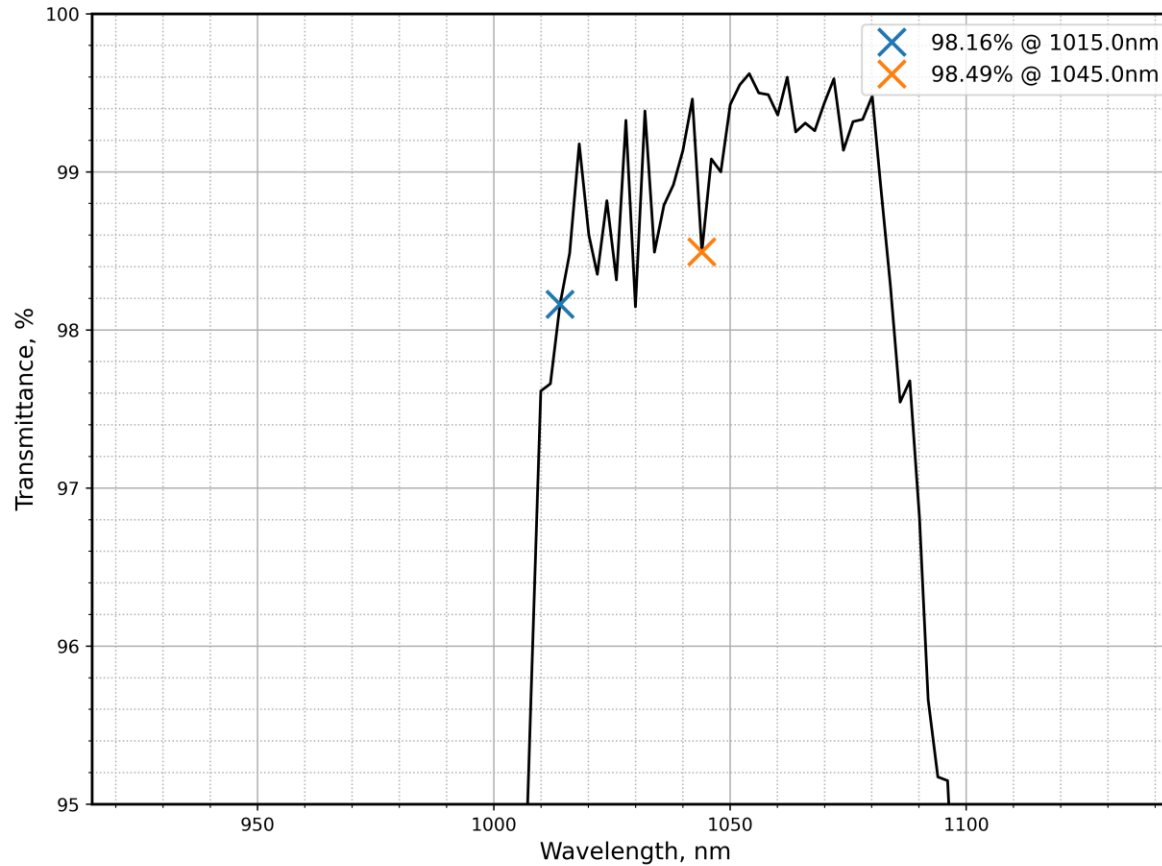
PO7662 Tp i68

Fig. 4.

SIDE MEASURED: S1+S2 (good component)

COMMENTS:

S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI = 68(+/-0.5) deg  
S2:  $AR_p(R_p < 0.5\%, R_s < 20\%)$  @ 1010-1050 nm, AOI = 68(+/-0.5) deg



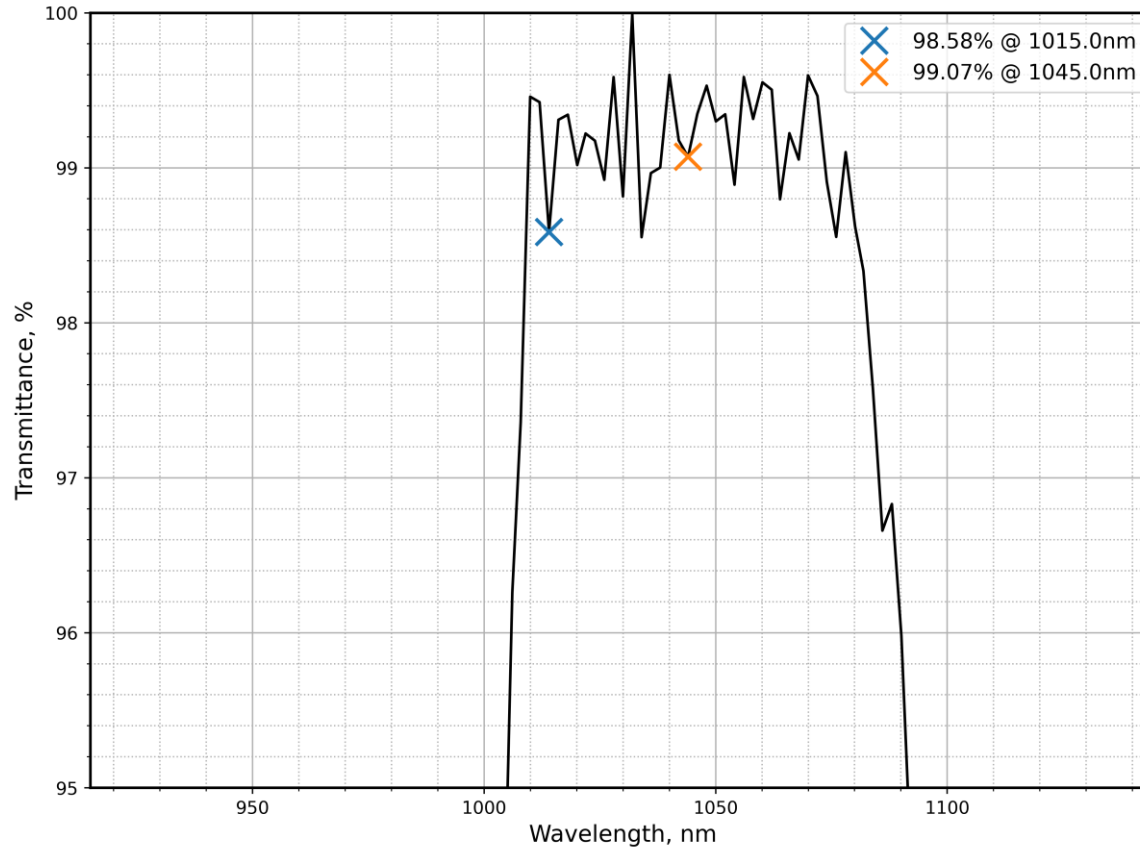
PO7662 Tp i68

Fig. 5.

SIDE MEASURED: S1+S2 (good component)

COMMENTS:

S1: (arrow marks)  $R_s > 99.9\%$  @ 1015 nm - 1045 nm;  $T_p > 98\%$ ,  $T_p/T_s > 1000$  @ 1015-1045 nm AOI=68(+/-0.5) deg  
 S2:  $AR_p(R_p < 0.5\%, R_s < 20\%)$  @ 1010-1050 nm, AOI=68(+/-0.5) deg



PO7662 Tp i68

Fig. 6.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: